

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Serial No.: 09/912,982

Filed: July 25, 2001

For: DIFFERENTIAL PRESSURE

APPLICATION APPARATUS FOR USE IN

POLISHING LAYERS OF SEMICONDUCTOR DEVICE STRUCTURES AND METHODS

Confirmation No.: 6766

Examiner: S. Macarthur

Group Art Unit: 1763

Attorney Docket No.: 2269-4375US

(99-1029.00/US)

Notice of Allowance Mailed:

September 14, 2004

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL994829059US

Date of Deposit with USPS: December 14, 2004

Person making Deposit: Steve Wong

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

A Listing of the Claims begins on page 6 of this paper.

Remarks begin on page 11 of this paper.